S	eai	ch	N	ote	es:	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/714,116	HAMILTON ET AL.
Examiner	Art Unit
Chen-Wen Jiang	3744

SEARCHED					
Class	Subclass	Date	Examiner		
62	186 418 259.2				
361	695 688				
	689 690				
	691 694				
165	104.33				
	80.3	4/5/2007	Cl		
Search	Updated	8/16/2007	C1		

		INTERFERENCE SEARCHED						
Subclass	Date	Examiner						
259.2	8/16/2007	CJ						
		·						

DATE 8/16/2007	EXMR
8/16/2007	CJ